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Technical data sheet **Differential Interferometer** SP 5000 DI Series



System parameter	SP 5000 DI	SP 5000 DI/F
Measurement range	0 m to ≥ 5 m	
Resolution	5 pm*	
Angular measurement range		
with reflector	±12.5° **	±15° **
with plane mirror (recommended distance ≤ 2 m)	±1.5 arcmin	±1.5 arcmin
Angular resolution	0.001 arcsec***	0.0015 arcsec***
Beam distance (standard)	21 mm	14 mm
Temperature sensitivity	<20 nm/K	<10 nm/K
Wavelength	632.8 nm	
Frequency stability of the HeNe laser (after warm-up time)	2·10 ⁻⁸	
Warm-up time of the HeNe laser	1020 min	
Operating temperature range	1530°C	
Maximum displacement speed of measuring reflector	3 m/s	
Geometric Data		
Dimensions (L x W x H):		
Sensor head (with base plate)	[150 x 140 x 43] mm	[110 x 65 x 33] mm
Electronic evaluation and supply unit EU (standard)	[450 x 400 x 150] mm	
Mass:		
Sensor head	2.0 kg	1.1 kg
Base plate	1.5 kg	-
Electronic evaluation and supply unit EU (standard)	ca. 8 kg	
Electrical Data		
Interfaces standard other interfaces on request (/R)	RS232C, USB	
Cable length between sensor head and electronics unit	3 m, optionally up to 10 m	
Power supply	100240 VAC / 4763 Hz	
Laser safety class according to EN 60825-1:2014 and ANSI Z136.1 (CDRH)	2M II	
n frequency domain ** rotary point dependent ***least significant bit (LBS) 09/2019 · Subject to change		





Extremely stable laser interferometer for high-precision length or angle measurements

CE

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Laser interferometer measurement system

SP 5000 DI

Our ultra-stable differential laser interferometer SP 5000 DI is characterised by its unique thermal stability and can be used for long-term measurements in research and development, such as for material testing.

Thanks to its design, with an external reference beam, the measurement system can be placed at a longer distance from the measurement location without significantly affecting



the resolution or stability of the measurement. The length resolution of the interferometer is 5 pm and this can be achieved even under normal laboratory conditions thanks to the differential principle of the measurement system.

The measurement range for length measurement is several meters if tilt-invariant reflectors are used for the measurements. The system has a modular design and can therefore be adapted to specific measurement tasks.

Adjustments can be made simply and with long-term stability. The construction of multi-axis systems on the basis of the SP 5000 DI interferometer also allows multi-coordinate measurements.

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± 1.5 arcmin with plane-mirror ± 15° with reflector

0.001 arcsec

2 m with plane-mirror 5 m with reflector

0.1 µm/m

5 pm



Further possible applications:

- The differential laser interferometer is available as an OEM version for installation as an encoder in machine axes. The SP 5000 DI is also available as a vacuum-optimised version for taking measurements in a vacuum.
- The standard beam distance is 21 mm. We can provide other beam distances on enquiry.

Ideal for

- Long-term measurements
- Development

- Science/research
- Exacting stability requirements
- OEM applications

PRECISION & QUALITY MADE IN GERMANY

For customer-specific versions, OEM applications or integration in special measurement stations, please contact us.

We will be happy to personally assist you in finding solutions for your measuring tasks.

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SP 5000 DI/F (A035977) Beam spacing 14mm



all dimensions in mm

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